



PATENT  
81877.0012

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Seiyo Nakashima et al.

Serial No: 09/816,643

Filed: March 23, 2001

For: SUBSTRATE PROCESSING APPARATUS  
AND SUBSTRATE PROCESSING  
METHOD

Art Unit: 1763

Examiner: Kackar, Ram N

**PETITION FOR EXTENSION OF TIME**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to:

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450, on  
June 30, 2004

Date of Deposit

Anthony J. Orler, Reg. No. 41,232

Name

*Anthony J. Orler*

06/30/04

Signature

Date

Dear Sir:

In accordance with 37 C.F.R. 1.136, Applicant respectfully petitions the Commissioner for a three-month extension of time extending to June 30, 2004, the period for response to the Office Action dated December 30, 2003. A check for \$950 is enclosed. The responsive paper(s) are attached.

Please charge any insufficiency or credit any overpayment to Deposit Account No. 50-1314. A copy of this petition is enclosed.

Respectfully submitted,

HOGAN & HARTSON L.L.P.

By: *Anthony J. Orler*

Anthony J. Orler

Registration No. 41,232

Attorney for Applicant(s)

Date: June 30, 2004

500 South Grand Avenue, Suite 1900  
Los Angeles, California 90071  
Phone: 213-337-6700  
Fax: 213-337-6701